

Application/Control No.	Applicant(s)/Patent under Reexamination	•
10/709,599	OHMORI, TADASHI	
Examiner	Art Unit	
Long Nguyen	2816	

SEARCHED					
Class	Subclass	Date	Examiner		
327	108-112, 172, 379, 389, 391, 309, 310,	6/20/05	CN		
	312,313, 317,318, 319,323, 327,328, 333	-			
326	23-24, 26,17, 80-83	V			

INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
Search	above	6/21/05	w			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DAT	
East	6/4/	of w